Title: METHOD OF FABRICATING X-RAY MASK AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE WITH X-RAY MASK FABRICATED BY THIS METHOD Inventors: WATANABE et al.

FIG.1

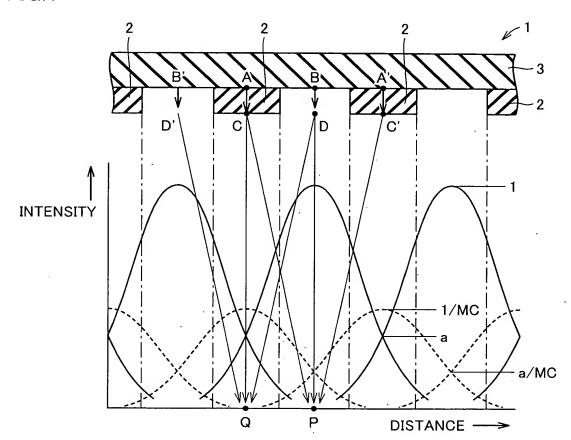
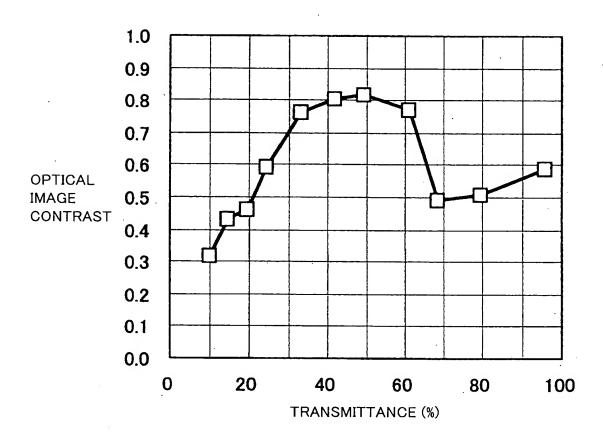
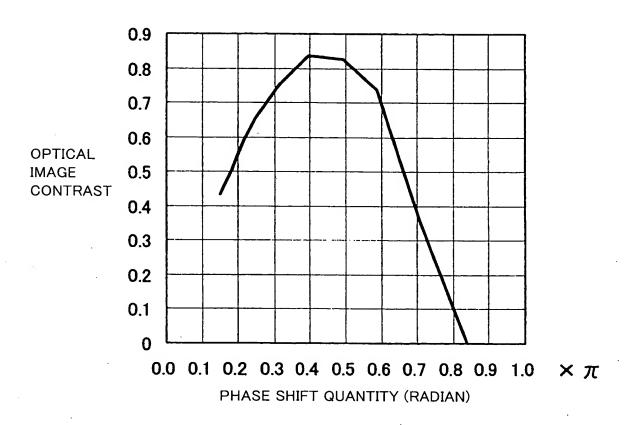


FIG.2



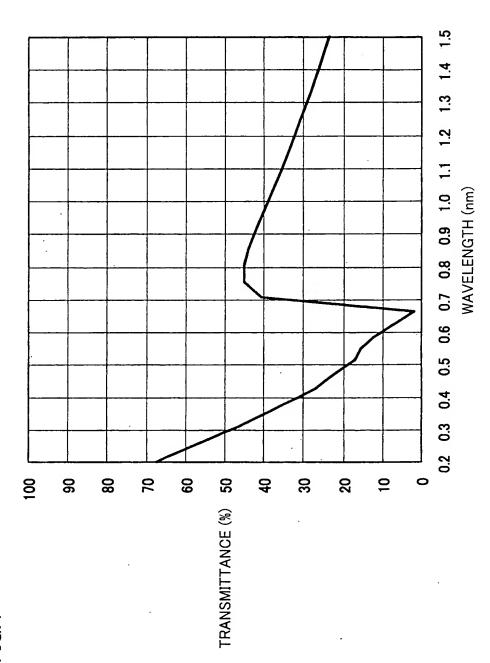
WITH X-RAY MASK FABRICATED BY THIS METHOD
Inventors: WATANABE et al.
Atty Docket No.: 402721
Leydig, Voit & Mayer 202-737-6770

FIG.3



Inventors: WATANABE et al.
Atty Docket No.: 402721
Leydig, Voit & Mayer 202-737

202-737-6770

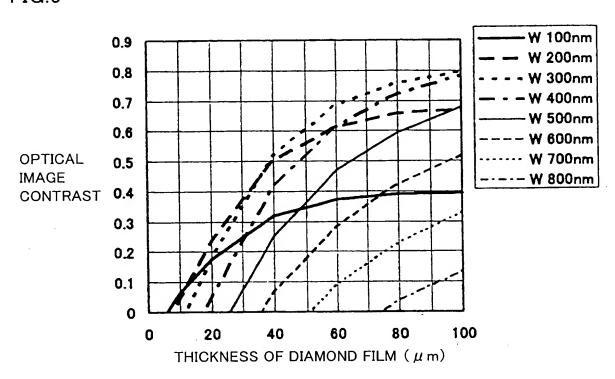


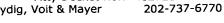
Inventors: WATANABE et al.

Atty Docket No.: 402721

Leydig, Voit & Mayer 202-737-6770

FIG.5





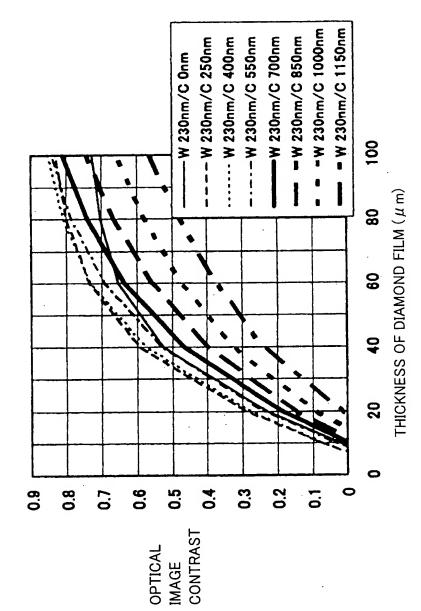


FIG.7

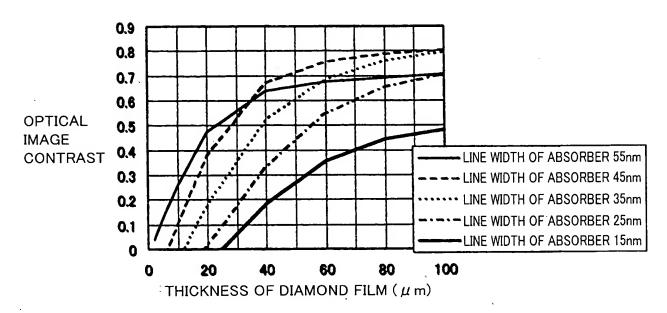
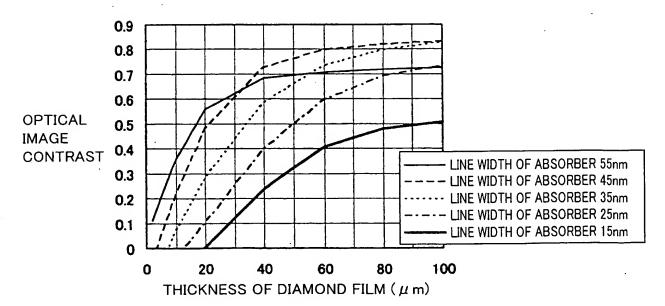
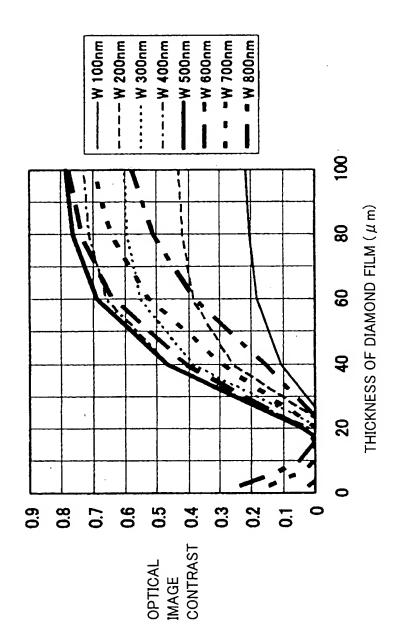


FIG.8



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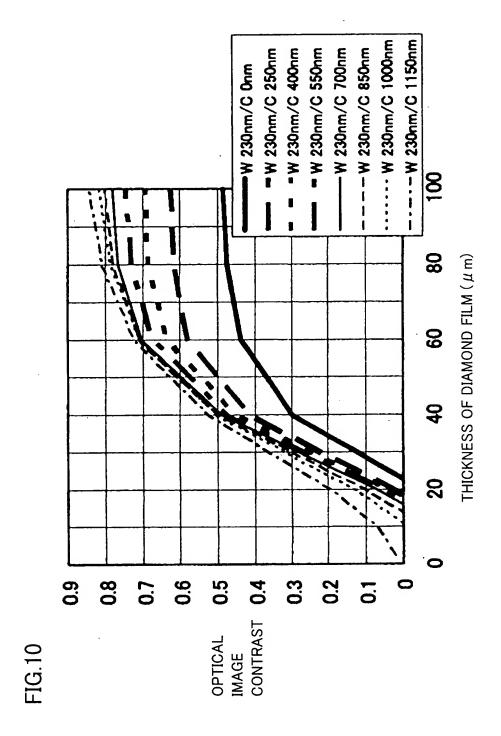


FIG.11

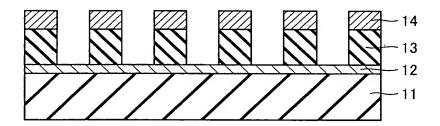


FIG.12

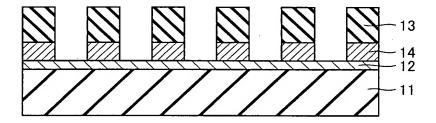


FIG.13

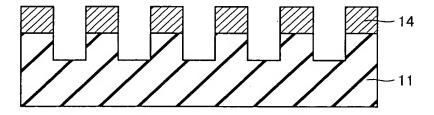


FIG.14

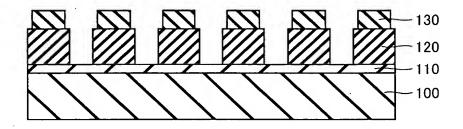
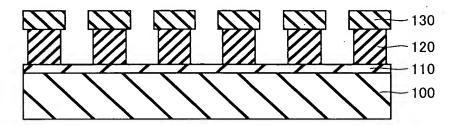


FIG.15



Title: METHOD OF FABRICATING X-RAY MASK AND METHOD OF FABRICATING SEMICONDUCTOR DEVICE WITH X-RAY MASK FABRICATED BY THIS METHOD Inventors: WATANABE et al.

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FIG.16

